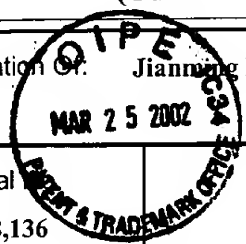


1753

<b>TRANSMITTAL OF INFORMATION DISCLOSURE STATEMENT</b> (Under 37 CFR 1.97(b) or 1.97(c))			Docket No. AM-2390.D2	
In Re Application Of: <b>Jianming FU</b>				
Serial 09/918,136	Filing Date July 30, 2001	Examiner S. Versteeg	Group Art Unit 1753	
Title: <b>SELF IONIZED SPUTTERING USING A HIGH DENSITY PLASMA SOURCE</b>				
Address to: <b>Assistant Commissioner for Patents</b> <b>Washington, D.C. 20231</b>				
<b>37 CFR 1.97(b)</b>				
1. <input checked="" type="checkbox"/> The Information Disclosure Statement submitted herewith is being filed within three months of the filing of a national application other than a continued prosecution application under 37 CFR 1.53(d); within three months of the date of entry of the national stage as set forth in 37 CFR 1.491 in an international application; before the mailing of a first Office Action on the merits, or before the mailing of a first Office Action after the filing of a request for continued examination under 37 CFR 1.114.				
<b>37 CFR 1.97(c)</b>				
2. <input type="checkbox"/> The Information Disclosure Statement submitted herewith is being filed after the period specified in 37 CFR 1.97(b), provided that the Information Disclosure Statement is filed before the mailing date of a Final Action under 37 CFR 1.113, a Notice of Allowance under 37 CFR 1.311, or an Action that otherwise closes prosecution in the application, and is accompanied by one of:				
<div style="display: flex; justify-content: space-between;"> <div> <input type="checkbox"/> the statement specified in 37 CFR 1.97(e);         </div> <div> <b>OR</b> </div> <div> <input type="checkbox"/> the fee set forth in 37 CFR 1.17(p).         </div> </div>				



#6/10.m.  
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## TRANSMITTAL OF INFORMATION DISCLOSURE STATEMENT

(Under 37 CFR 1.97(b) or 1.97(c))

Docket No.  
AM-2390.D2

In Re Application Jianming FU

Serial No.

09/918,136

Filing Date

July 30, 2001

Examiner

S. Versteeg

Group Art Unit

1753

SELF IONIZED SPUTTERING USING A HIGH DENSITY PLASMA SOURCE

## Payment of Fee

(Only complete if Applicant elects to pay the fee set forth in 37 CFR 1.17(p))

- ☐ A check in the amount of \_\_\_\_\_ is attached.
- ☒ The Assistant Commissioner is hereby authorized to charge and credit Deposit Account No. 50-0636 as described below. A duplicate copy of this sheet is enclosed.
- ☐ Charge the amount of \_\_\_\_\_
- ☒ Credit any overpayment.
- ☒ Charge any additional fee required.

## Certificate of Transmission by Facsimile\*

I certify that this document and authorization to charge deposit account is being facsimile transmitted to the United States Patent and Trademark Office (F

(Date)

Signature

Typed or Printed Name of Person Signing Certificate

## Certificate of Mailing by First Class Mail

I certify that this document and fee is being deposited on March 12, 2002 with the U.S. Postal Service as first class mail under 37 C.F.R. 1.8 and is addressed to the Assistant Commissioner for Patents, Washington, D.C. 20231.

Signature of Person Mailing Correspondence

Ingrid C. Mallory

Typed or Printed Name of Person Mailing Certificate

\*This certificate may only be used if paying by deposit account.

Signature

Charles S. Guenzer, Reg. No. 30,640

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Mailing Address:

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Patent/Legal Department

P.O. Box 450A

Santa Clara, CA 95052

Dated: March 12, 2002

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CC: